03500.014241

## **PATENT APPLICATION**

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IN THE UNITED STATE	ES PATENT A	AND TRADEMARK OFFICE
pplication of:	)	
	:	Examiner: B. Talbot
HIRO ITO	)	
	•	Group Art Unit: 1762
ation No.: 09/505,627	)	
	•	
February 16, 2000	)	
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MANUFACTURING METH	HOD OF )	
ELECTRON BEAM APPAR	RATUS:	
AND SPACER, AND ELEC	TRON )	
BEAM APPARATUS	:	March 13, 2006
ssioner for Patents		
ox 1450		
	pplication of: HIRO ITO  ation No.: 09/505,627  February 16, 2000  MANUFACTURING METHELECTRON BEAM APPARAND SPACER, AND ELECTED BEAM APPARATUS  ssioner for Patents	HIRO ITO  ation No.: 09/505,627  bebruary 16, 2000  MANUFACTURING METHOD OF ) ELECTRON BEAM APPARATUS: AND SPACER, AND ELECTRON ) BEAM APPARATUS  ssioner for Patents

Alexandria, VA 22313-1450

## **AMENDMENT**

Sir:

## A. Introductory Comments

In response to the Office Action dated December 14, 2005, please amend the application as follows and consider the following remarks.